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**CONFIRMATION NO. 6676** 

SERIAL NUMBER 10/21/2003 CLASS 438 GROUP ART UNIT 2813 ATTORNEY DOCKET NO. 501.43182X00  APPLICANTS  Yoshiyuki Abe, Hinode, JAPAN;  "CONTINUING DATA  "FOREIGN APPLICATIONS JAPAN 2002-310787 10/25/2002  IF REQUIRED, FOREIGN FILING LICENSE GRANTED  "02/09/2004  Foreign Priority claimed 35 USC 119 (a-d) conditions met Not Markowided and Acknowledged Westerniner's Signature 19/4 Date 19/	BID Data Sheet									
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